



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 6839

<b>SERIAL NUMBER</b> 10/017,396	<b>FILING DATE</b> 12/18/2001 <b>RULE</b>	<b>CLASS</b> 428	<b>GROUP ART UNIT</b> 1771	<b>ATTORNEY DOCKET NO.</b> PF-2088DIV	
<b>APPLICANTS</b> Kazuhiko Endo, Tokyo, JAPAN;					
<b>** CONTINUING DATA *****</b> THIS APPLICATION IS A DIV OF 09/093,193 06/08/1998 - <i>Roche 428/307.3</i>					
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 09-150762 06/09/1997					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 03/26/2002</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>12/18/01</i> Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 18	<b>TOTAL CLAIMS</b> 38 <i>16</i>	<b>INDEPENDENT CLAIMS</b> 2 <i>3</i>
<b>ADDRESS</b> 000466					
<b>TITLE</b> <i>Method of Forming A</i> Silica insulation film with a reduced dielectric constant and <del>method of forming the same</del>					
<b>FILING FEE RECEIVED</b> 1064	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		

4A  
12-1904